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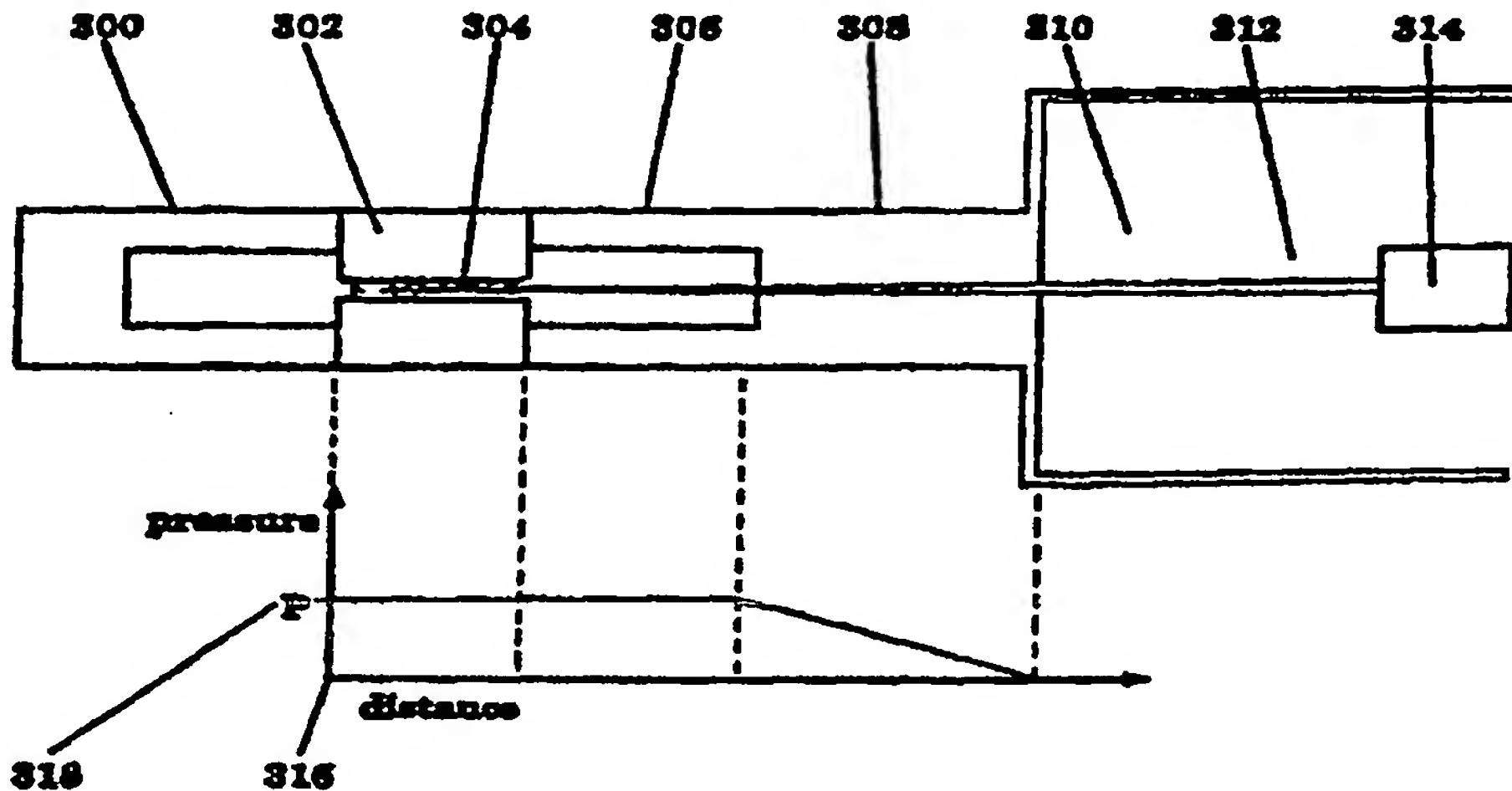


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(71) Applicant: UNIVERSITY OF CENTRAL FLORIDA [US/US]; 4000 Central Florida Boulevard, ADM-423, Orlando, FL 32816-0150 (US).		
(72) Inventors: SILFVAST, William, T.; 1362 Sylvaner Avenue, St. Helena, CA 94574 (US). KLOSNER, Marc, A.; Apartment 304, 10836 Glen Cove Circle, Orlando, FL 32817 (US). SHIMKAVEG, Gregory, M.; 3566 Scoutoak Loop, Oviedo, FL 32765 (US).		
(74) Agent: STEINBERGER, Brian, S.; 101 Brevard Avenue, Cocoa, FL 32922 (US).		

(54) Title: DISCHARGE LAMP SOURCES APPARATUS AND METHODS

Experimental arrangement for obtaining spectral data



(57) Abstract

A capillary discharge extreme ultraviolet lamp source apparatus and method for extreme ultraviolet microlithography. The capillary source includes a lamp body (306); a bore having electrodes (300), insulators (302) and a discharge plasma region (304).

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